

# MULTI-GHz PULSE-TRAIN X-BAND CAPABILITY FOR LASER COMPTON X-RAY AND $\gamma$ -RAY SOURCES\*

D. J. Gibson<sup>†</sup>, G. G. Anderson, S. G. Anderson, R. A. Marsh, M. J. Messerly,  
M. A. Prantil, C. P. J. Barty, LLNL, Livermore, CA 94550, USA

## Abstract

A wide variety of light-source applications would benefit from increased average brightness, which generally corresponds to increasing average current in the driving accelerator. Presented is an accelerator architecture that is capable of producing hundreds of electron bunches, spaced as close together as every RF cycle, which provides the chance to increase current while maintaining beam quality. This system relies on an X-band photoinjector and a photoinjection drive laser that is driven by the same rf source to ensure synchronization, and an interaction laser system designed to match the duty cycle of the electron pulse train. Results of the photoinjector laser performance and initial experimental measurements of beam quality in accelerated bunch trains are presented, along with a discussion of the impact on the performance of tunable, narrow-bandwidth x-ray and  $\gamma$ -ray beams based on Compton-scattering.

## INTRODUCTION

While some photonic applications, such as time resolved imaging, require a large number of photons in a short time (i.e. a high peak brightness), many applications (medical imaging, nuclear resonance fluorescence measurements, material assay, etc.) don't have such a stringent requirement and can benefit from increasing not only the peak brightness of the source, but also the average brightness.

In a Compton-scattering based source, a high intensity laser beam scatters a high brightness electron beam and generates x-rays with an energy of

$$E_{\gamma} = \frac{2\gamma^2(1 - \cos\varphi)}{1 + \gamma^2\theta^2} h\nu$$

ignoring recoil, where  $\gamma$  is the electron Lorentz factor,  $\varphi$  is the incidence angle between the electrons and photons,  $\theta$  is the observation angle relative to the electron direction of travel, and  $\nu$  is the laser frequency. Properly apertured, such a beam can provide a very narrow bandwidth, easily tunable x-ray or  $\gamma$ -ray source. The number of scattered x-rays depends on the overlap integral between the laser and electron beam and therefore is a function of electron and photon density. To increase the flux from an electron bunch, the options include: focusing the beam harder, which increases the angular spread and therefore broadens the bandwidth; increase the charge, which will increase the beam emittance, with a similar result on the spectrum; or increase the laser

energy, which is limited by the introduction of nonlinear scattering effects with also broaden the beam bandwidth.

As has been discussed elsewhere [1], very little of the laser energy is used in the scattering process. Sending more electron bunches, rather than more electrons in a single bunch, can make efficient reuse of the unscattered laser photons. This is the motivation for putting electrons into every accelerating RF bucket, increasing in the average current of between 10x and 100x and resulting in a comparable increase in x-ray flux. Accomplishing this in practice requires a photoinjector-based accelerator architecture capable of pumping energy into the electrons without inter-bunch wakefield effects destroying the beam, a photoinjection laser system capable of generating precisely timed multi-GHz pulses to generate the electrons, and an interaction laser designed to interact with a train of pulses, rather than a single pulse.

## DRIVE LASER

The architecture for a laser capable of generating a multiple-GHz pulse train is described in detail in Ref. [2]. The 11.424 GHz RF that drives the accelerator is frequency divided to 5.712 GHz and used to an electro-optic modulator. A 1040-nm cw laser pulse passes through the modulator and is carved into an 11.424 GHz pulse train. This pulse train then passes through a series of amplifiers and acousto-optic modulators, resulting in 50 ns bursts of pulses at a 28 kHz repetition rate with 150 mW of average power. This beam then passes through 300 m of single mode optical fiber, where self phase modulation generates bandwidth with a nearly linear chirp on the individual pulses. These chirped pulses then pass through a large-mode-area photonic crystal fiber and a small grating pair compressor, resulting in a laser with 5  $\mu$ J per micropulse, 500 micropulses per burst, and a 28 kHz burst rate.

To allow accelerator demonstration in parallel with laser development, an Amplitude Ti:Sapphire laser system is used in place of the multi-GHz system. Up to 20 mJ of uncompressed 780 nm laser light at 10 Hz is transported to the accelerator hall, where the pulses are compressed to 200 fs and frequency tripled to 260 nm. In order to generate multiple pulses, a hyper-Michelson pulse stacker [3] is used. Tests to date have been conducted with four pulses, but up to 16 can be generated with the existing system hardware. The beam is then apertured to provide a sharp radial edge, typically with a 0.5 mm diameter, but other diameter are available. The apertured beam is then relay imaged to the photoinjector cathode, providing typically 10  $\mu$ J per pulse in the UV.

\* This work was performed under the auspices of the U.S. Department of Energy by Lawrence Livermore National Laboratory under Contract DE-AC52-07NA27344.

<sup>†</sup> gibson23@llnl.gov

Content from this work may be used under the terms of the CC BY 3.0 licence (© 2015). Any distribution of this work must maintain attribution to the author(s), title of the work, publisher, and DOI.

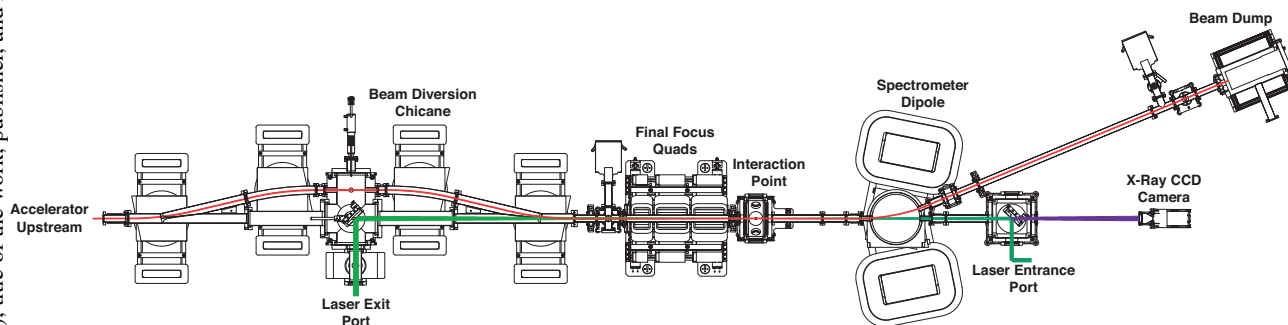


Figure 1: Cross section interaction region of the laser-Compton system. The accelerator sits to the left of the figure. The electron (red), laser (green) and x-ray (purple) paths are shown.

## ACCELERATOR

The accelerator is built around a state-of-the-art X-band RF photoinjector [4]. RF power is provided by a 50 MW 11.424 GHz SLAC built XL4 klystron powered by a solid-state Scandinova modulator. The RF power provided is of very high phase and power stability, providing excellent electron beam consistency. A 5.59 cell RF gun incorporates LCLS S-band gun improvements, producing 7 MeV submicron emittance bunches in excess of 100 pC. The electron beam energy is boosted by a T53 traveling wave accelerator section to a maximum of 31 MeV. A chicane is used to shield x-ray experiments from dark current and allow for an interaction laser exit path. The electron beam energy is measured with a dipole spectrometer and captured in a shielded dump. Other diagnostics include ICTs, YAG screens, and OTR measurements. A more detailed status of the X-band test station can be found in [5].

Initial optimization is made with all but the fixed-delay arm of the hyper-Michelson pulse stacker blocked. After optimization of the beam performance for a single electron bunch, the beam blocks in the hyper-Michelson are adjusted to allow a different single bunch through. A Schottky scan is performed with this pulse. The results are used to dial in the delay of the hyper-Michelson arm to deliver the laser pulse at the optimal 20° operational phase, but with a single RF-period delay. This process is repeated for the second delay arm, inserting a 2-period delay and yielding a 4-pulse bunch train with each bunch separated by a single 87.5 ps RF cycle. This spacing is verified by a streak camera measurement of optical transition radiation (OTR) light from the beam (Fig. 2). The energy of each electron bunch is verified, and when tuned correctly the bunch-to-bunch spread is comparable to the single bunch energy spread.

The emittance of multiple simultaneous bunches is currently being measured. Preliminary results show no significant degradation of performance between single-bunch and multiple-bunch operation. Beam dynamics modeling is underway to distinguish the effect of bunch-to-bunch emittance growth and statistical variation in the images used for the quad scan parameter fitting. Ultimately, streaked OTR-based quadrupole scans will be able to simultaneously

measure the emittance of each bunch, and confirm operation of Laser-Compton sources in multibunch modes.

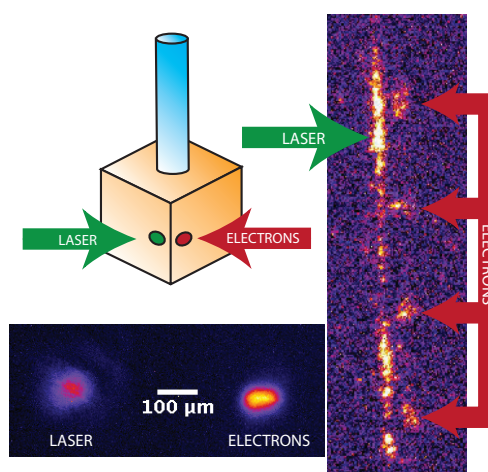


Figure 2: Left top: Alignment configuration. Left bottom: laser and electron OTR at the interaction point. Right: Streak camera image with a portion of the interaction laser alongside OTR from four electron bunches with 87.5 ps spacing.

## INTERACTION

Fig. 1 shows the design of the interaction region. As mentioned above, the electron beam passes through a chicane which allows for a tungsten plug to be inserted on axis to reduce dark current bremsstrahlung noise on the x-ray detector. The beam is then focused with a quadrupole triplet and, after interaction, passes through an energy spectrometer which separates the electron beam from the x-rays.

Meanwhile, the 9 mm diameter interaction laser beam is enlarged to 18 mm before being focused with a 1.5 m lens. The beam passes through the vacuum window, and is directed by a final optic to the interaction point. Because the x-ray beam will have to pass through this mirror, a hole has been counterbored in the back of the optic to reduce the fused silica thickness to 2 mm where the x-ray beam passes through. After the interaction, the beam is collected by a mirror in the middle of the chicane and directed into a beam dump.

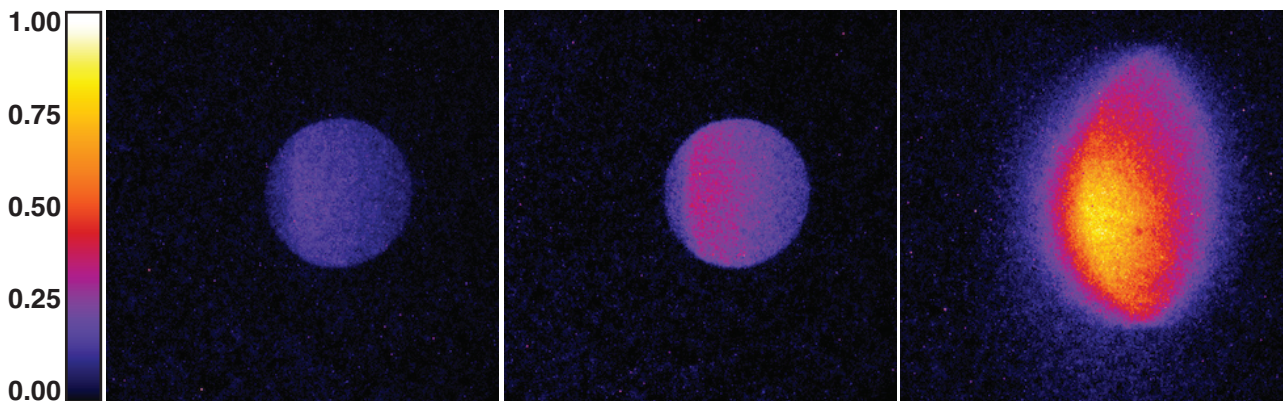


Figure 3: X-ray images with (left) one, (center) two, and (right) four electron bunches interacting with a single laser pulse. The one and two bunch images are clipped by an alignment iris, which was removed for the four-bunch experiment.

The electron beam and laser were aligned using a Ni cube aligned at 45 degrees to the beamline, which directs the attenuated laser beam and optical transition radiation from the electron beam to either a standard camera or a streak camera. Fig. 2 shows a streaked image verifying the spacing of four adjacent electron bunches, spaced 87.5 ps apart, alongside a portion of the interaction laser pulse.

### PRELIMINARY X-RAY RESULTS

For the x-ray demonstration, we used a Continuum Powerlite DLS 8010 laser, providing up to 750 mJ of 532 nm light with a 6 ns FWHM pulse length. This long length means that most of the light won't see the 2 ps long electron beam, so the flux will be 100x smaller than it could be with a shorter laser. For purposes of studying the electron beam performance, however, it is sufficient. Fig. 4 shows the expected flux for this interaction as a function of laser focal spot size, which was chosen to optimize x-ray generation

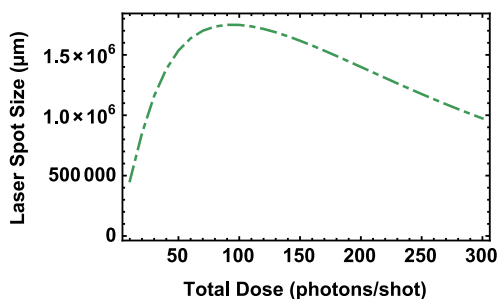


Figure 4: Predicted total flux as a function of laser focal spot size for a 750 mJ, 6 ns, 532 nm laser interacting with a single 100 pC, 0.4 mm mrad, 30 MeV electron bunch.

The generated x-rays were detected by a 145  $\mu\text{m}$  CsI(Tl) scintillator layer grown on a fiber plate, which is coupled to a 3:1 fiber reducing bundle. This bundle is in turn coupled to a gated, intensified Andor iStar ICCD camera. 3 shows the measured x-ray profile for one, two and four bunches on the same color scale. The aperture shown is a 12 mm diameter located at a distance of 1.5 m from the interaction

point, corresponding to an 8 mrad beam cone. These images show, as expected, a roughly linear increase in x-ray flux with the total beam current. The imaging system response has not yet been calibrated to allow conversion of measured counts into energy deposited.

### CONCLUSION

LLNL's laser-Compton source is operational and now offers a valuable test bed to optimize all areas of source development. Initial tests show promise for the multi-GHz architecture's ability to provide a higher-current beam, significantly improving laser Compton x-ray source performance. The next significant step is to integrate the multi-GHz laser system with the x-band accelerator and study the beam performance with 100 bunches and determine at what number of pulses, and what charge per pulse, the beam wakefield effects become to disruptive and explore any necessary mitigation.

### REFERENCES

- [1] M.Y. Shverdin, et al., *Opt. Lett.* 35, 2224 (2010).
- [2] M.A. Prantil, et al., *Opt. Lett.* 38, 3216 (2013).
- [3] C.W. Siders, et al., *Appl. Opt.* 37, 5302 (1998).
- [4] [R.A. Marsh, et al., *Phys Rev ST Accel Beams* 15, 102001 (2012).
- [5] R.A. Marsh et al., "X-Band RF Photoinjector for Laser Compton X-Ray and Gamma-Ray Sources", TUPMA025, *These Proceedings*, IPAC'15, Richmond, USA (2015).